

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	:	
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Ellison et al.	:	Attorney Docket: 31257-252090
	:	
Application No.: 10/526,059	:	Art Unit: 4174
	:	
Filed: October 13, 2005	:	Examiner: N. Gugliotta
Title: LIGHTLY DOPED SILICON CARBIDE WAFER AND USE THEREOF IN HIGH POWER DEVICES		

RESPONSE TO FINAL OFFICE ACTION

MAILSTOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the final office action issued May 23, 2008, please amend the above-identified application as follows: